

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Maher, et al.  
Appl. No. : 10/771,283  
Filed : February 2, 2004  
For : HIGH THROUGHPUT METHOD  
AND SYSTEM FOR SCREENING  
CANDIDATE COMPOUNDS FOR  
ACTIVITY AGAINST TARGET  
ION CHANNELS  
Examiner : S. E. Fernandez  
Group Art Unit : 1651

## AMENDMENT AND REQUEST FOR CONTINUED EXAMINATION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action of October 10, 2007, in the above-identified application, Applicants submit the following: